

Advanced Muon-Spin Spectroscopy Using Si-Pixel Detectors - A New Dawn for µSR



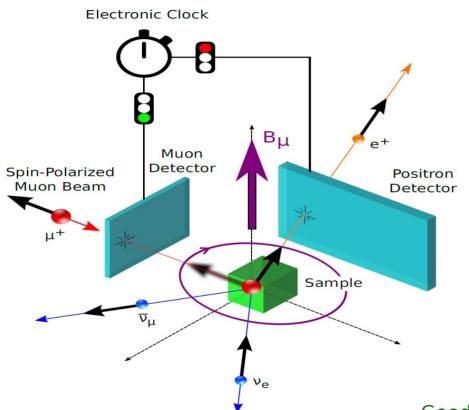


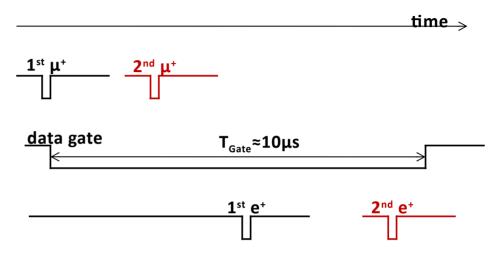
Outline

- μSR at PSI and its limitations
- What to overcome?
- Vertex Reconstructed μSR (vx-μSR)
- Detector technology
- First Si-Pixel μSR spectrometer
- Measurements and examples

μSR at PSI and its limitations







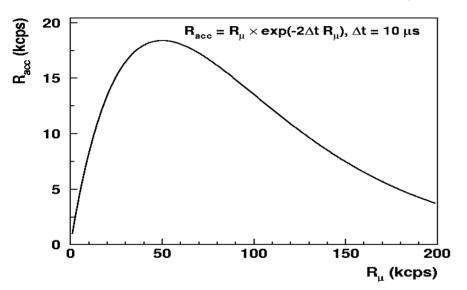
- 1st μ^+ : there was **no** other μ^+ for at least T_{Gate} in the past
- Single muon detection: only **one** μ^+ and **one** e^+ in observation window ($T_{\text{Gate}} \approx 10 \mu s$)
- Second μ^+ / e^+ rejection electronically and by rate limitation

Good Event = (data gate) $^{\circ}$ (1st e+) $^{\circ}$ (no 2nd μ +) $^{\circ}$ (no 2nd e+)

μSR at PSI and its limitations

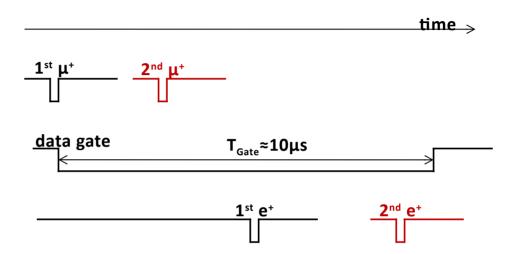






Current rate limit for $T_{Gate} = 10 \mu s$ is ~40k μ */s

100x more rate with HIMB



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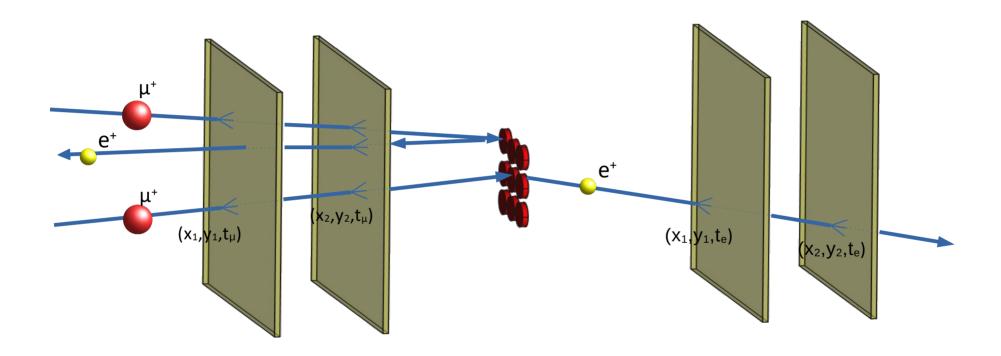
What are the limitation we want to overcome?



| | Current limit | Aim |
|--------------------|---|-----------------------|
| Incoming muon rate | < 40kHz @ 10µs | > 400 kHz @ 20µs |
| Sample size | > 4x4 mm ² | < 1x1 mm ² |
| Number of samples | One at a time | > 1 |
| Veto detectors | necessary | obsolete |
| Data gate length | 10μs or 20μs with MORE (muons on request) | 20-30µs |

Vertex Reconstruction Scheme





How to Produce Vertex Reconstructed µSR (vx-µSR)

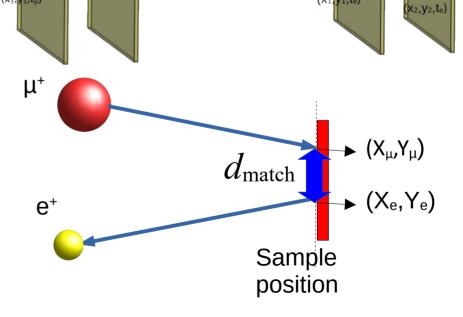


 (x_1, y_1, t_e)

• For each muon, look for a matching positron within a t_{gate} time (~12 μ s).

• Matching within d_{match} (~1mm) is allowed.

- If found, record:
 (X_μ,Y_μ), (X_e,Y_e) and (t_e-t_μ)
- Construct time histograms: upstream/downstream depending on the positron trajectory.
- The time histograms can be added for specific regions in the sample.



 (x_2,y_2,t_μ)

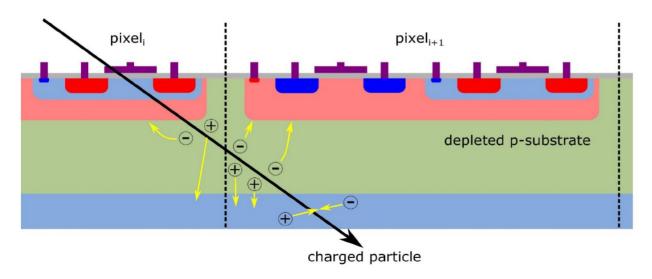
 (x_1, v_1, t_{11})

High-voltage monolithic active pixel sensor (HV-MAPS)



Si-Pixel detectors – MuPix11

- Developed by the Mu3e collaboration.
- 180 nm HV-CMOS process
- Fully integrated digital readout
- Can be as thin as 50 micrometers with 80×80 μm² pixel size
- Continuous readout without trigger
- Less than 20ns time resolution





Figures and details from Thomas Rudzky

See: https://archiv.ub.uniheidelberg.de/volltextserver/30885/

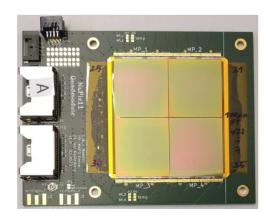
First Si-Pixel µSR Spectrometer

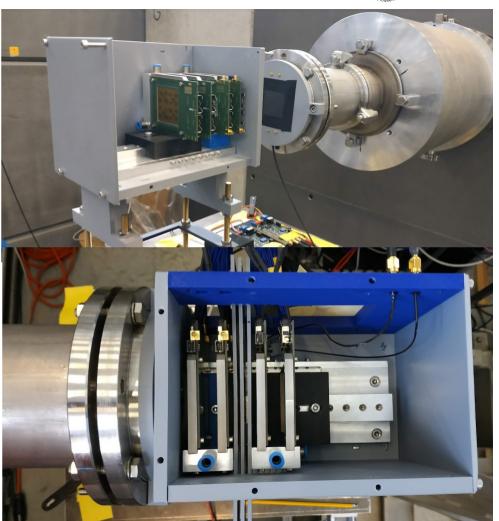


https://arxiv.org/abs/2503.08891

- Four layered spectrometer: upstream and downstream set
- MuPiX11 sensors: four chips per layer → active region of ~40 x 40 mm²
- Variable distance between upstream and downstream set
- Per pixel hit rate of >> 40 kHz possible

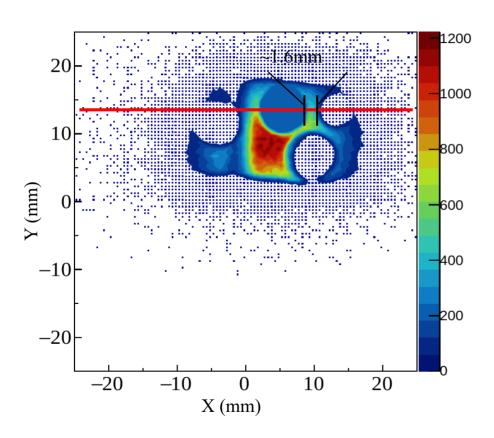
- In air
- No cryostat
- No magnet



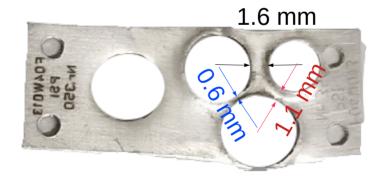


Lateral Resolution of vx-µSR Fine Details



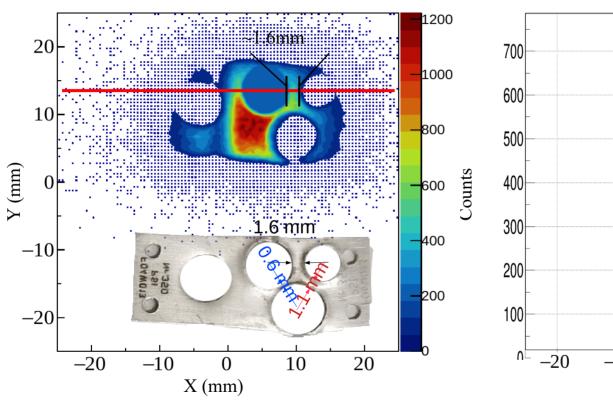


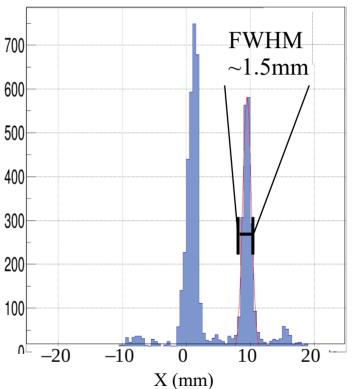
- Choose a sample with clear features
- Map the sample
- Extract cuts to examine features



Lateral Resolution of vx-µSR Fine Details

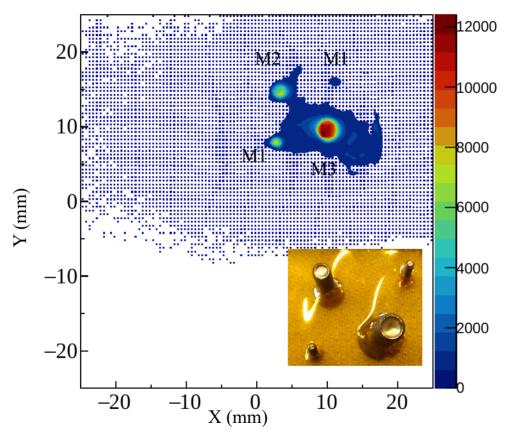






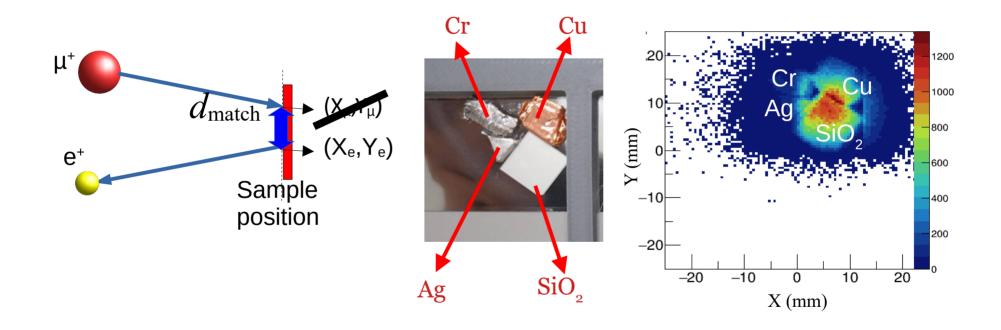
Lateral Resolution of vx-µSR Fine Details





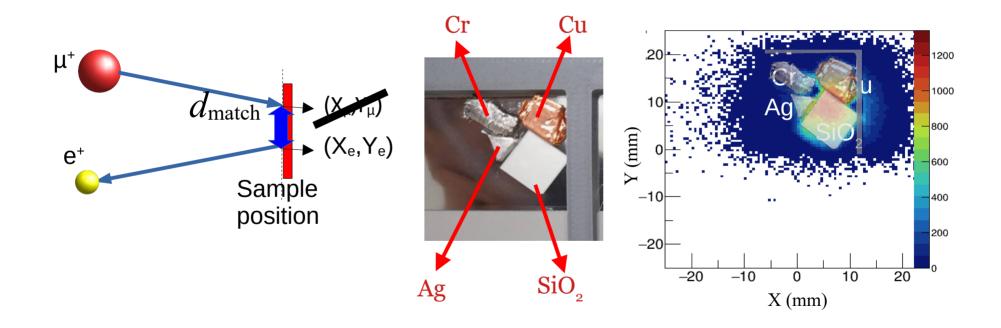
Lateral Resolution of vx-µSR Multiple Samples Simultaneously



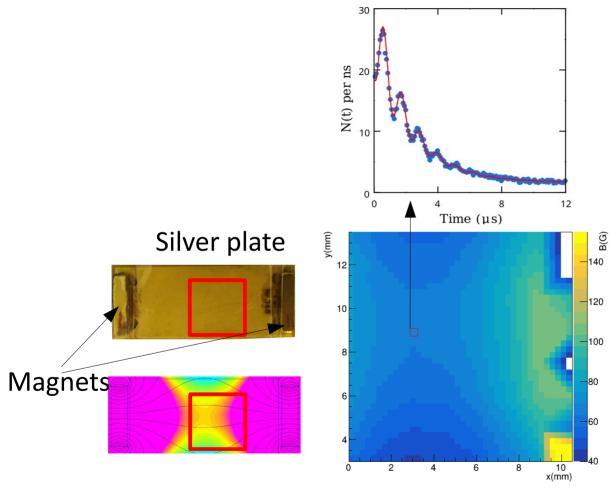


Lateral Resolution of vx-µSR Multiple Samples Simultaneously

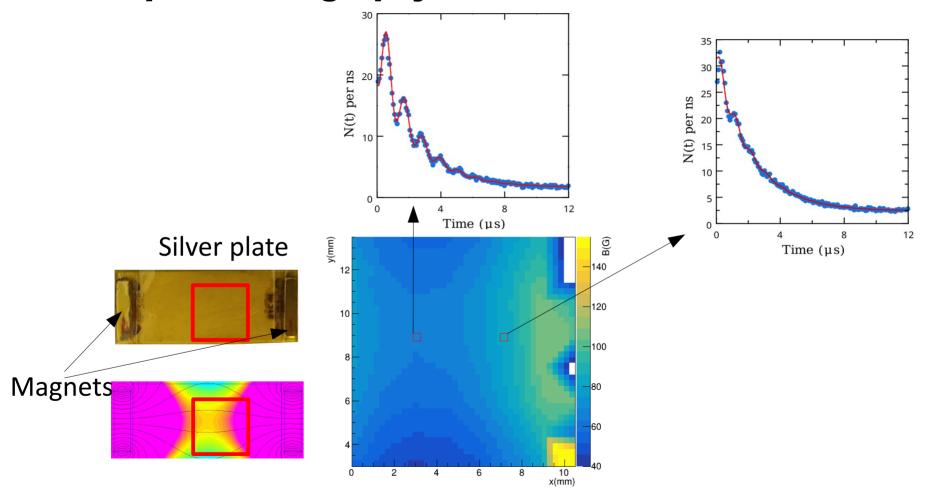




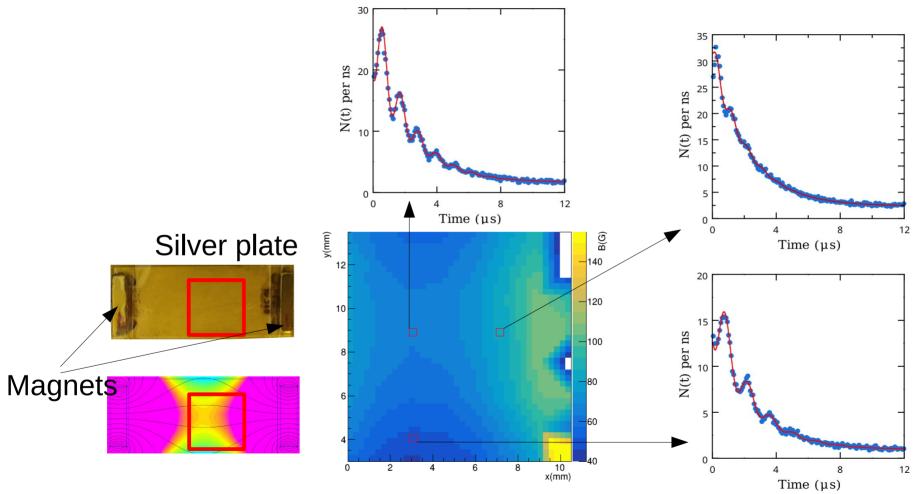




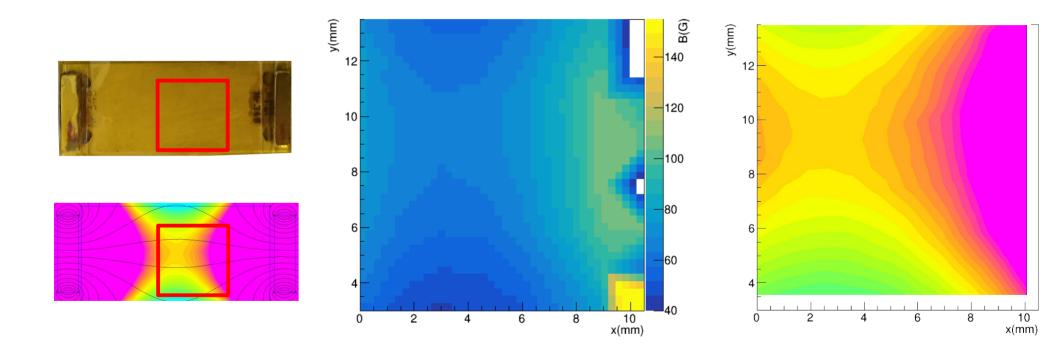




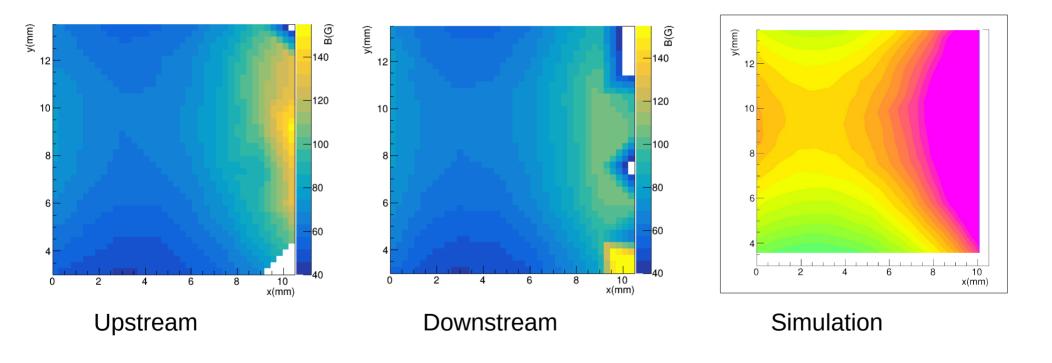




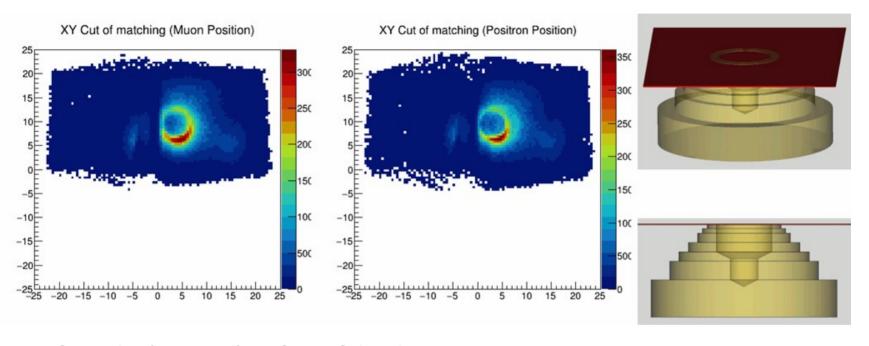






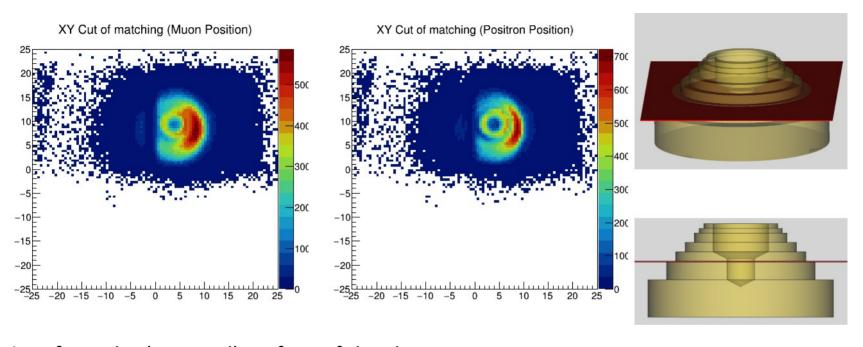






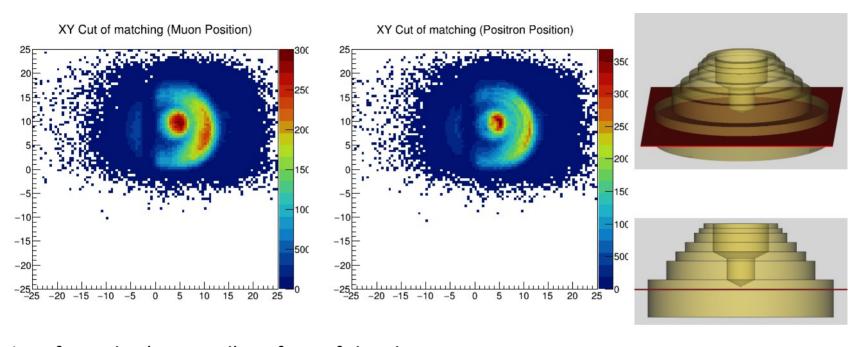
- Vertices from the (exposed) surface of the shape
- Steps of 1 mm
- Integrating layers of 1 mm thick in the beam direction





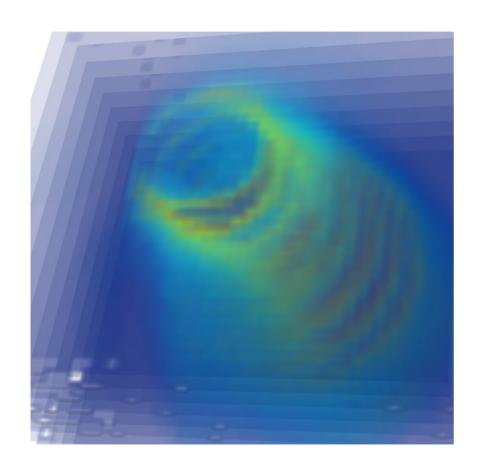
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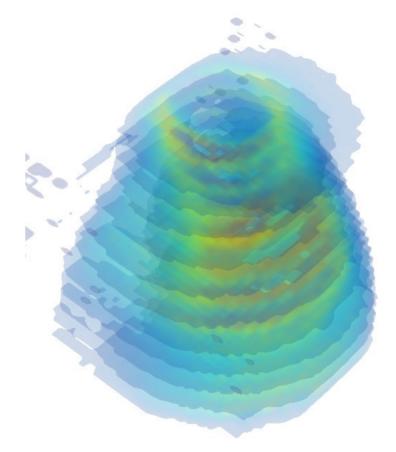


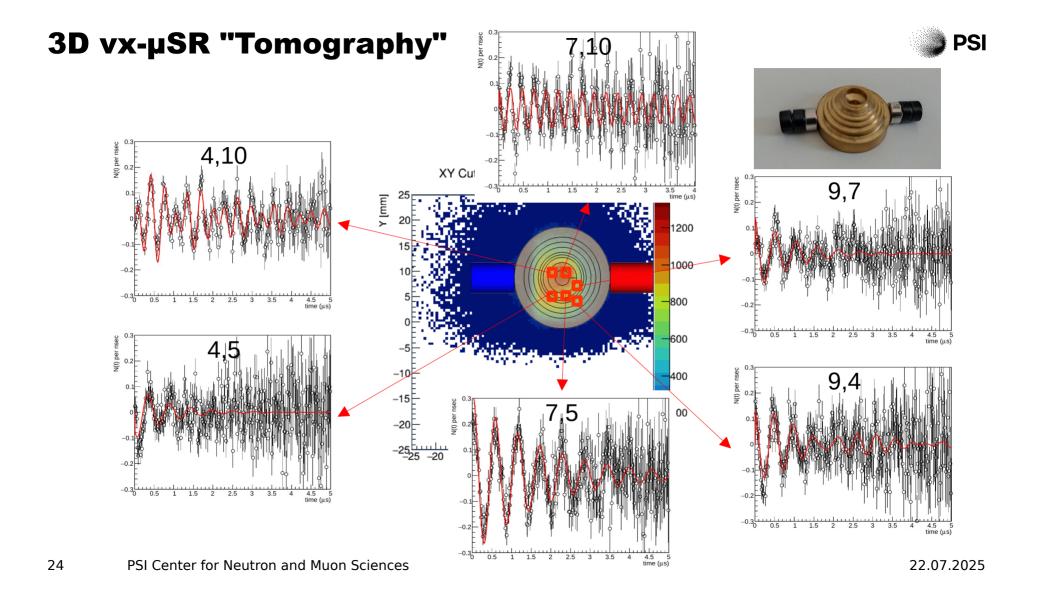


- Vertices from the (exposed) surface of the shape
- Steps of 1 mm
- Integrating layers of 1 mm thick in the beam direction
- Note the circle in the middle from the hole in the center









Conclusions

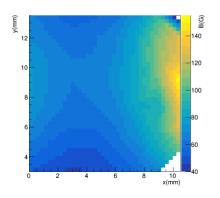


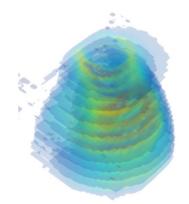
Operation at >200 kHz achieved

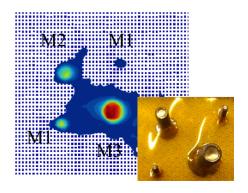
Sample sizes of $\sim 1 \times 1 \text{mm}^2$

Multiple samples distinguishable

3D surface tomography







Thanks to ...



PSI

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ETHz

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Mainz

Nick Berger



Join as a



PhD student



Postdoc